

# Influence Of Ballistic Effects In Ultra-Small MOSFETs

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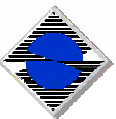
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# Contents

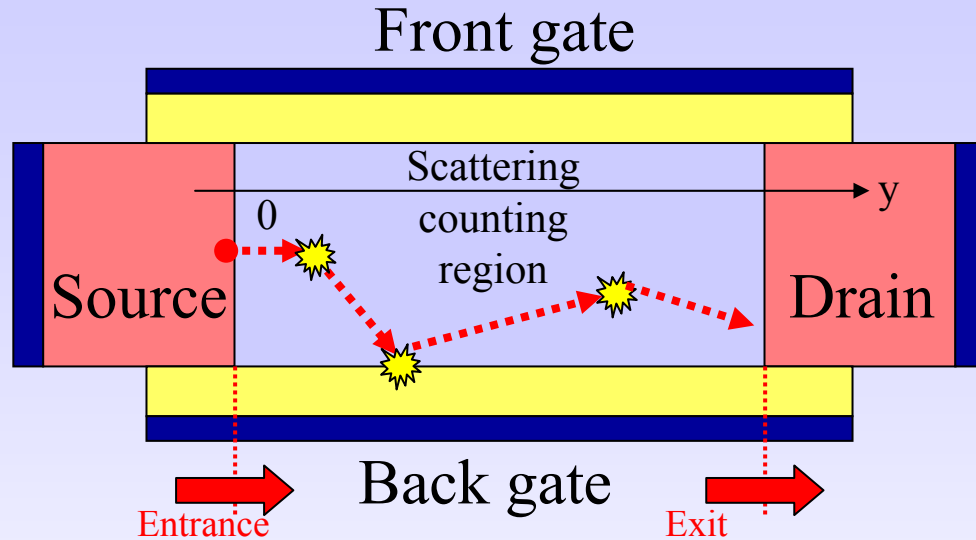
- Introduction
- Channel length and ballistic transport
- Bias dependence on ballisticity
- Ballisticity and long-channel effective mobility



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# Transport in decanano MOSFET



Quasi-ballistic transport: electron mean free path is similar to  $L_{\text{ch}}$

↓  
Monte Carlo  
simulation

•  $B_{\text{int}} = \%$  of ballistic electrons at the drain-end

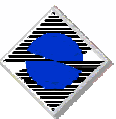
• 
$$B_{\text{eff}} = \frac{I_{\text{on}}}{I_{\text{on\_with\_a\_ballistic\_channel}}}$$



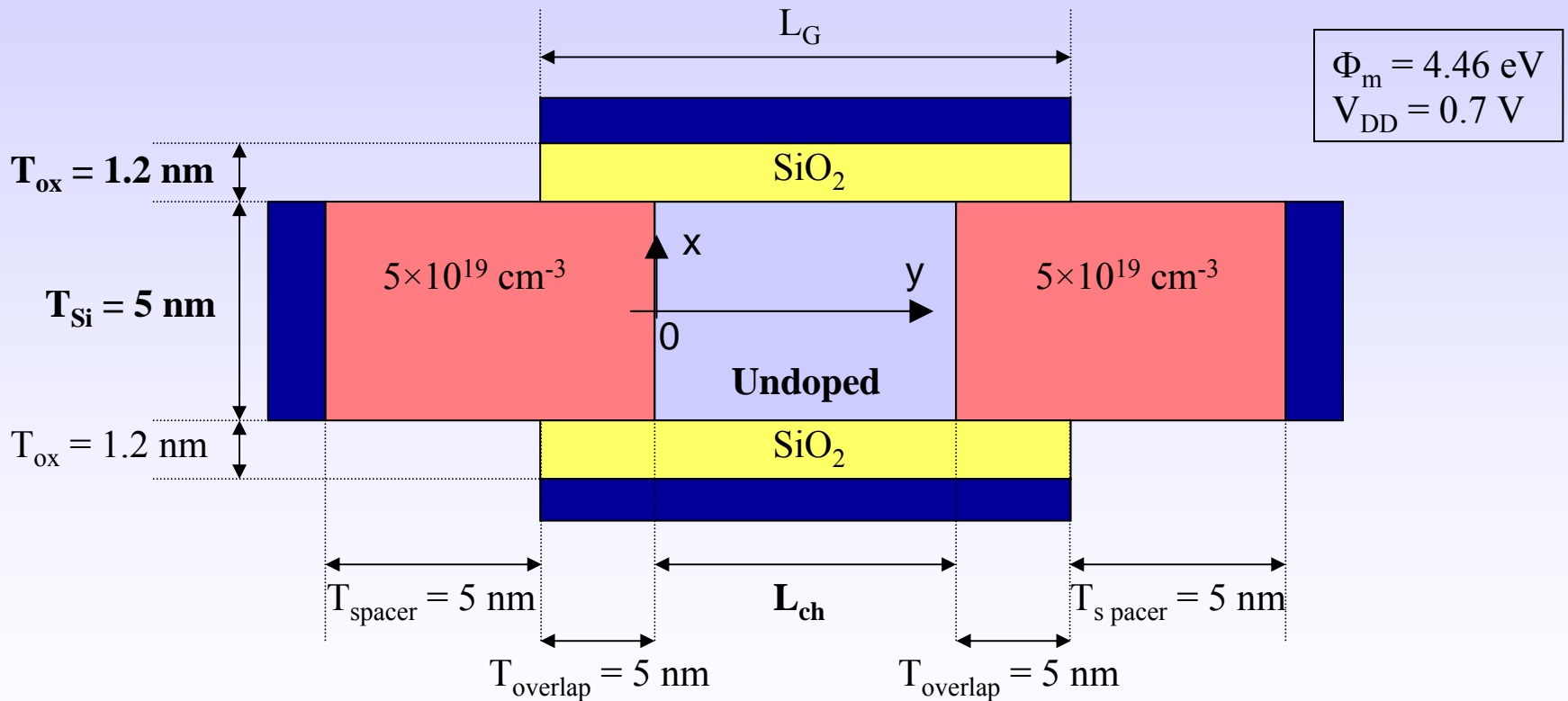
# Contents

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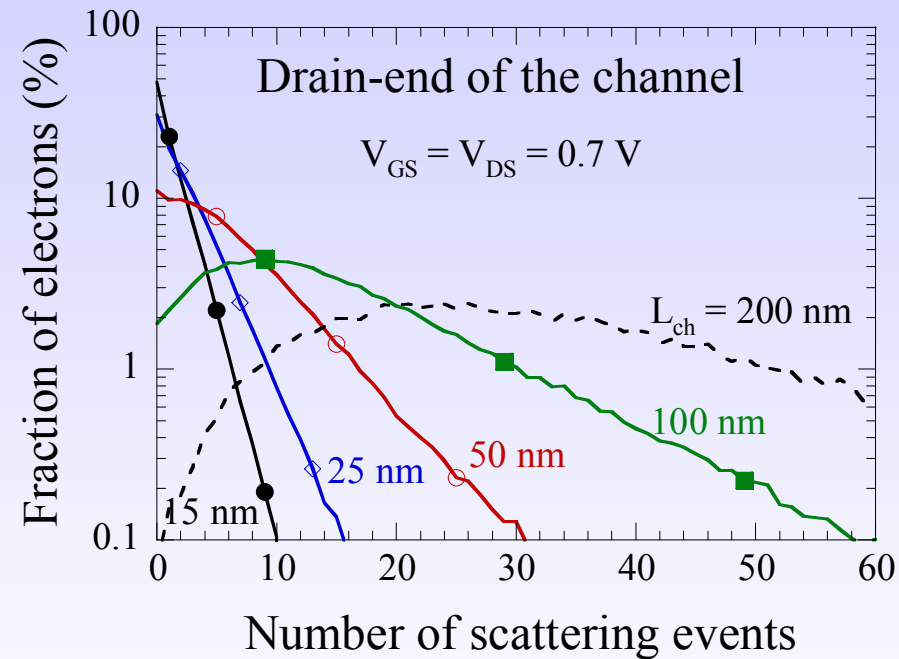
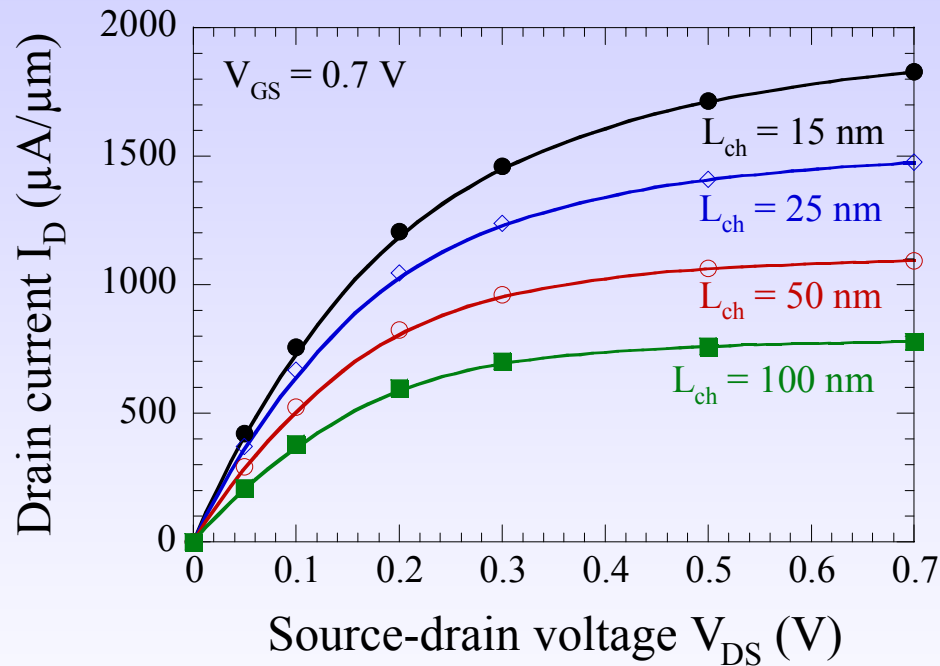
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# Studied devices



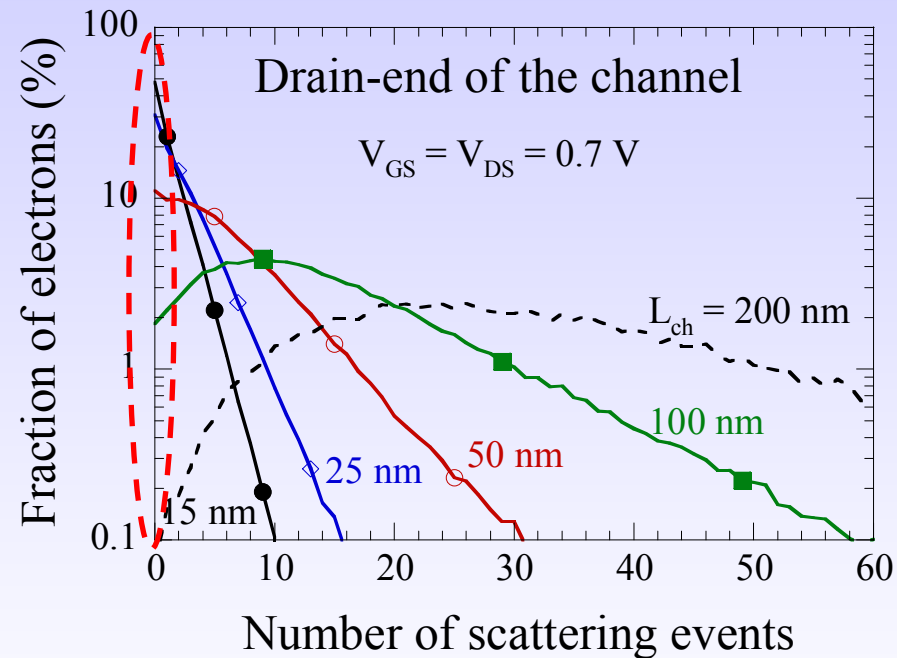
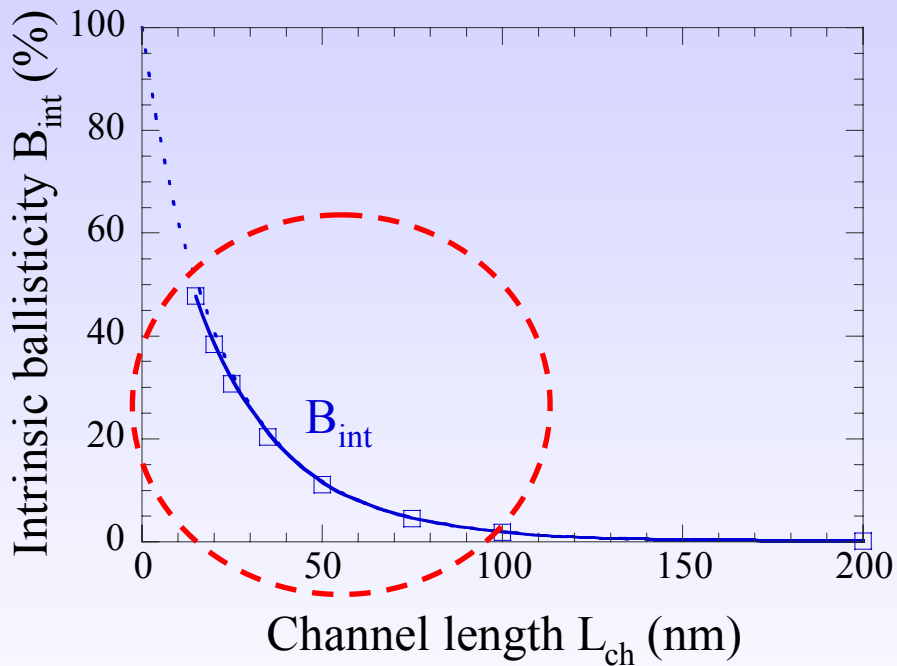
# From quasi-stationary to quasi-ballistic



➡ Transition for  $L_{ch} \approx 50$  nm in undoped channels



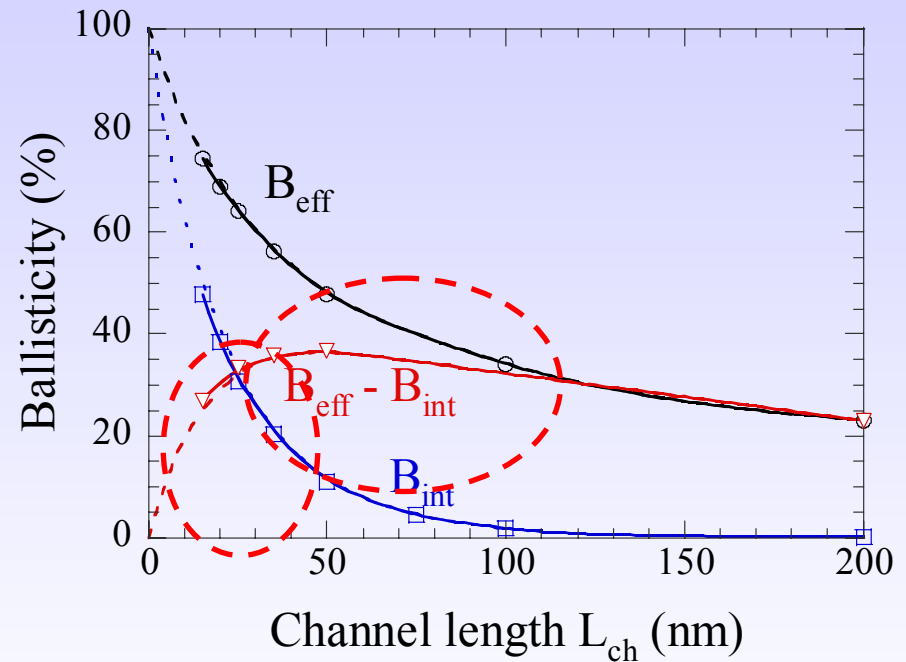
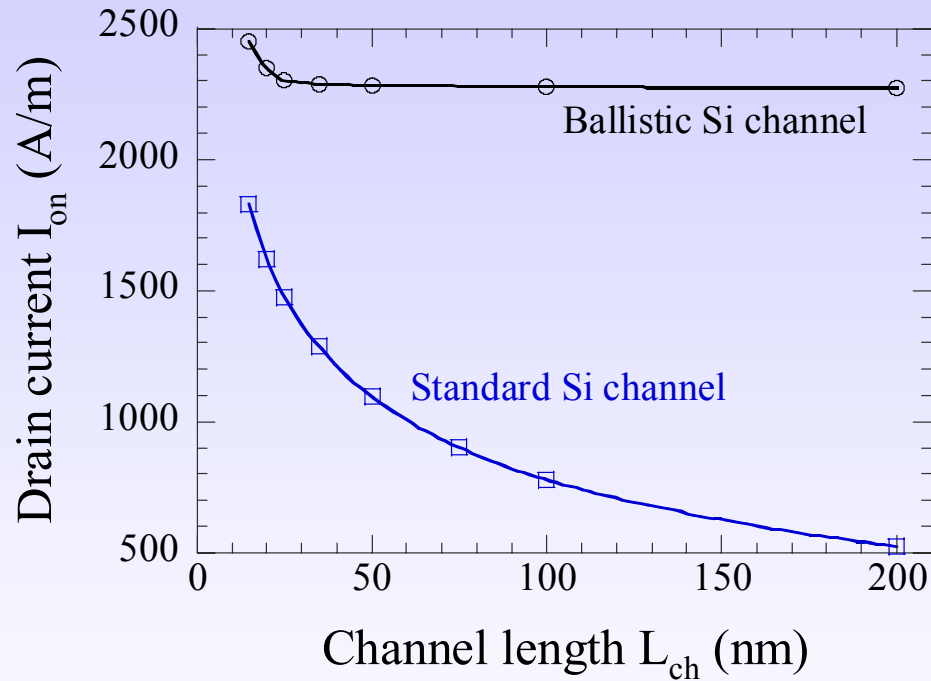
# Ballisticity and channel length



➔  $B_{int}$  strongly increases for  $L_{ch} < 100$  nm



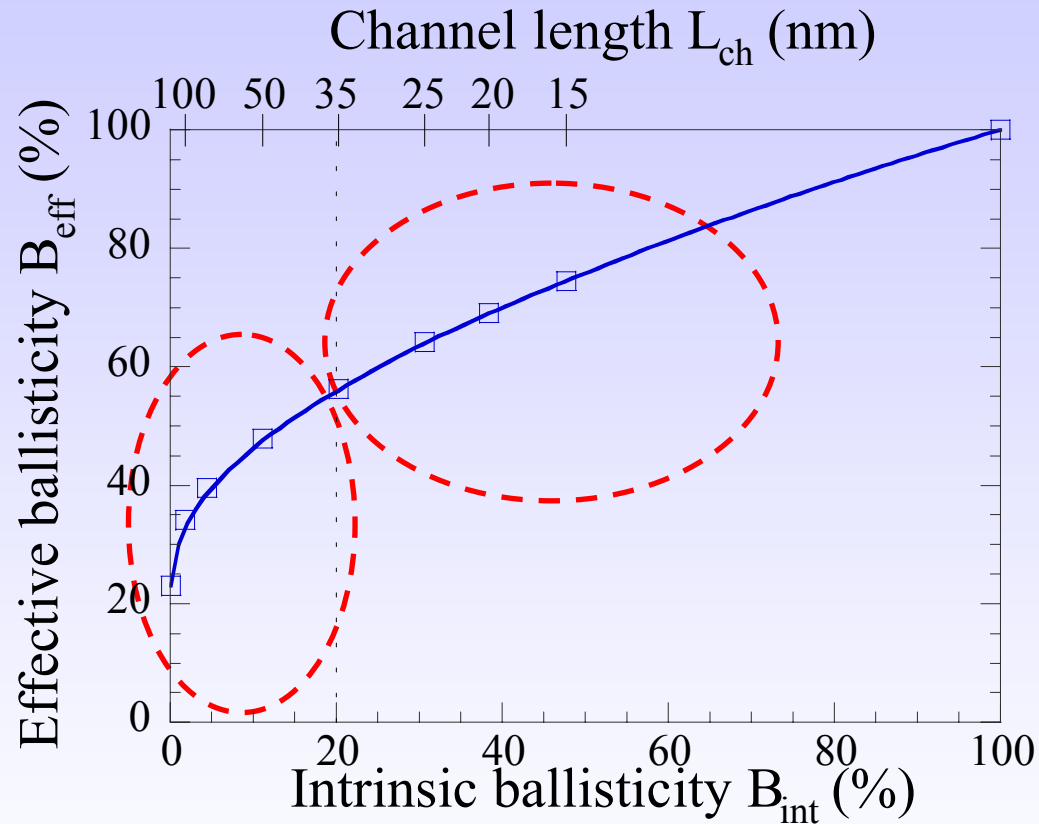
# Ballisticity and current



➔ Gap between  $B_{int}$  and  $B_{eff}$  no more constant for  $L_{ch} < 30$  nm



# $B_{\text{eff}}(B_{\text{int}})$ in undoped channels



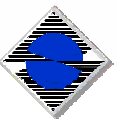
➔ Strong impact of  $B_{\text{int}}$  on  $B_{\text{eff}}$  for  $B_{\text{int}} < 20\%$

➔  $B_{\text{eff}}(B_{\text{int}})$ : quasi linear correlation for  $B_{\text{int}} > 20\%$

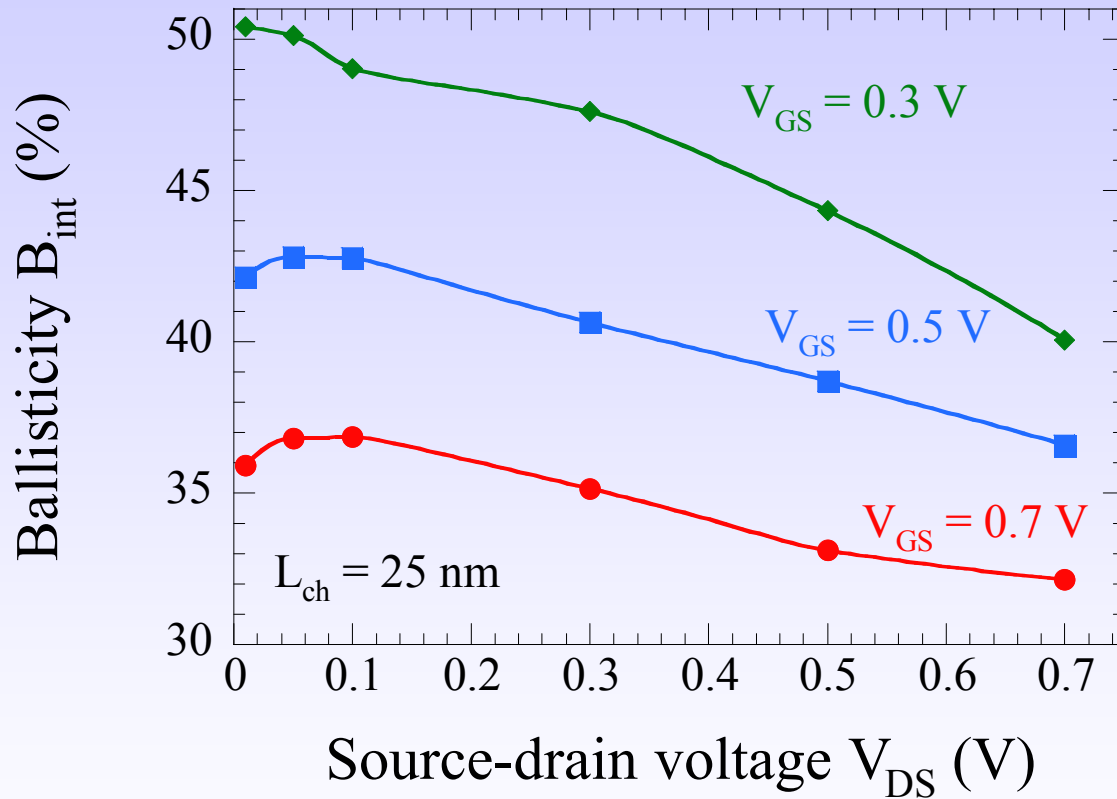
**Decreasing impact of  $B_{\text{int}}$  on  $B_{\text{eff}}$**

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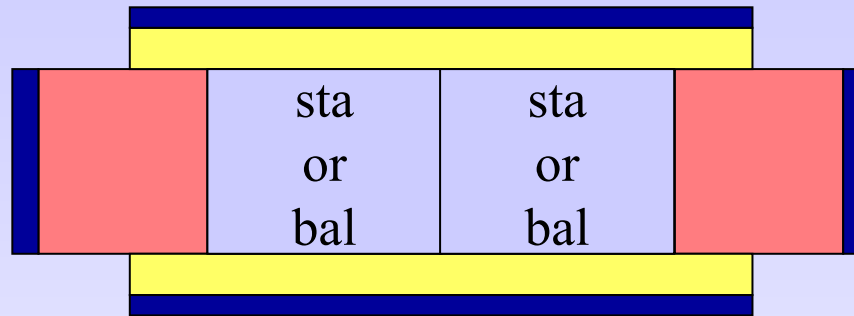
# $B_{\text{int}}$ as a function of $V_{\text{DS}}$ for different $V_{\text{GS}}$



➡  $B_{\text{int}}$  decreases when  $V_{\text{GS}}$  increases

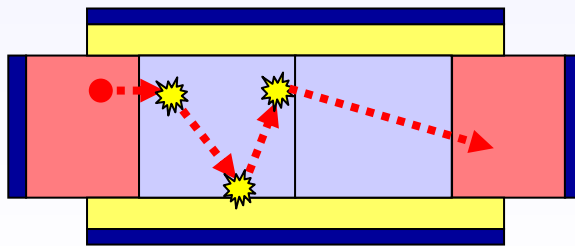
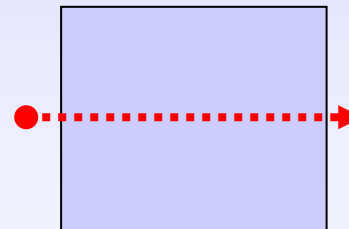
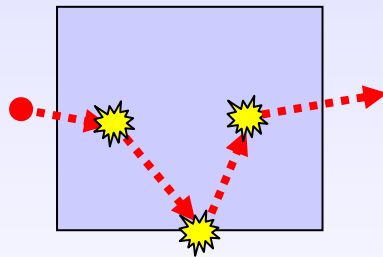
➡  $B_{\text{int}}$  decreases when  $V_{\text{DS}}$  increases

# 'Sta-bal' and 'bal-sta' architectures

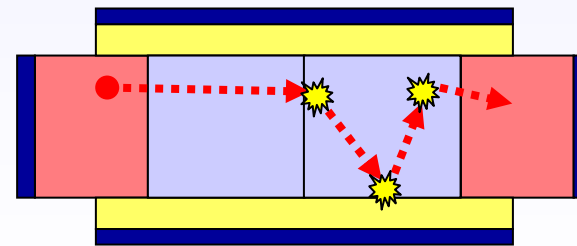


sta

bal

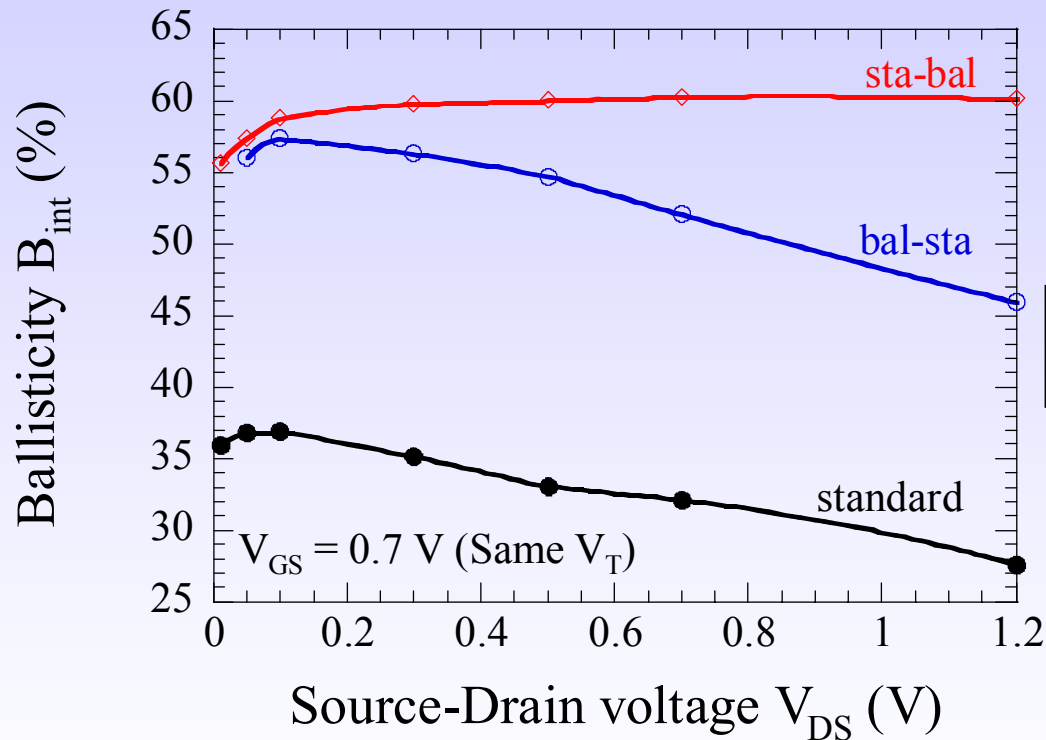


'sta-bal'



'bal-sta'

# $B_{\text{int}} (V_{\text{DS}})$ : 'sta-bal' vs. 'bal-sta'

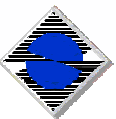


➔  $B_{\text{int}}$  decrease is due to scatterings in the 2<sup>nd</sup> half of the channel

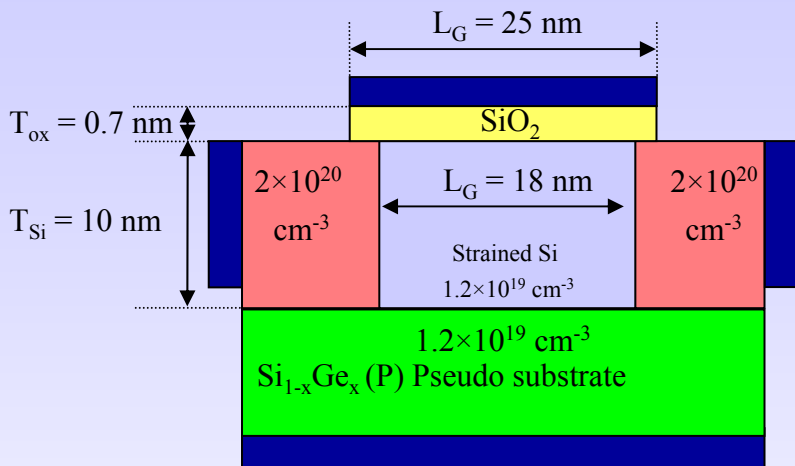
**Higher phonon scattering rate > driving field**

# Contents

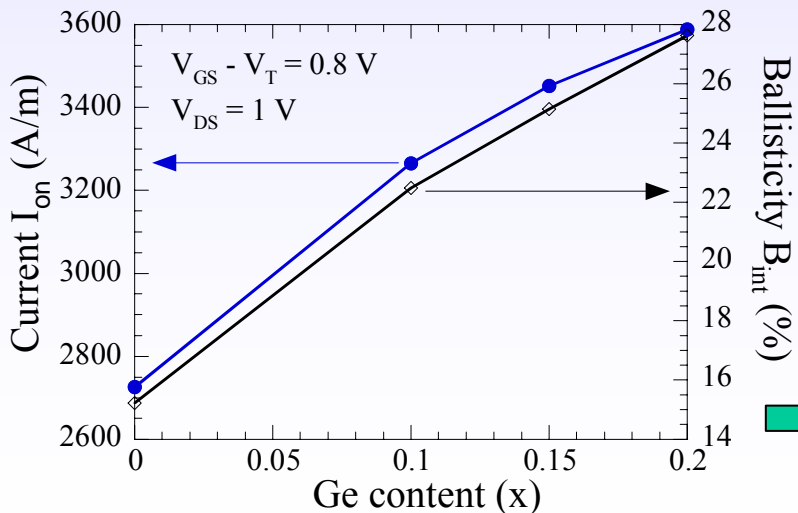
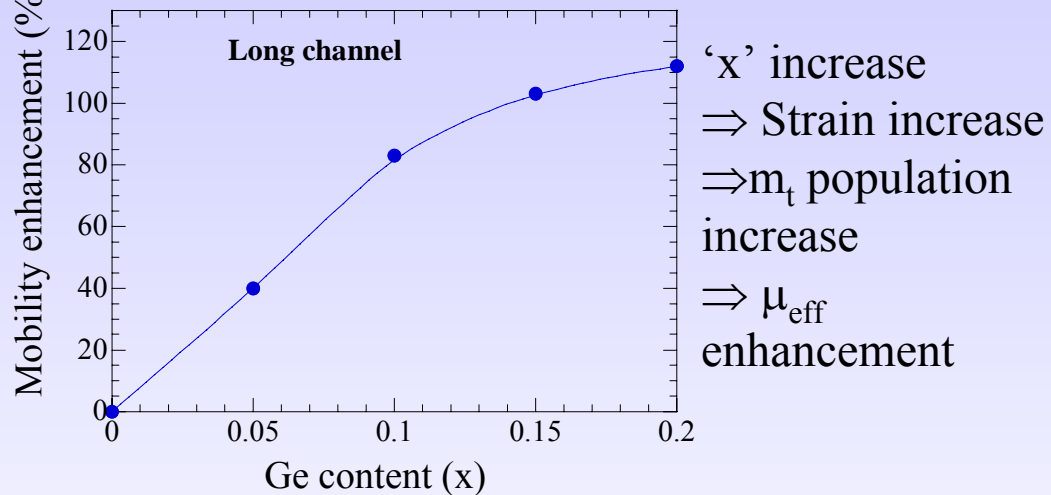
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# Studied strained SGMOS



V. Aubry-Fortuna *et al.*, to be published



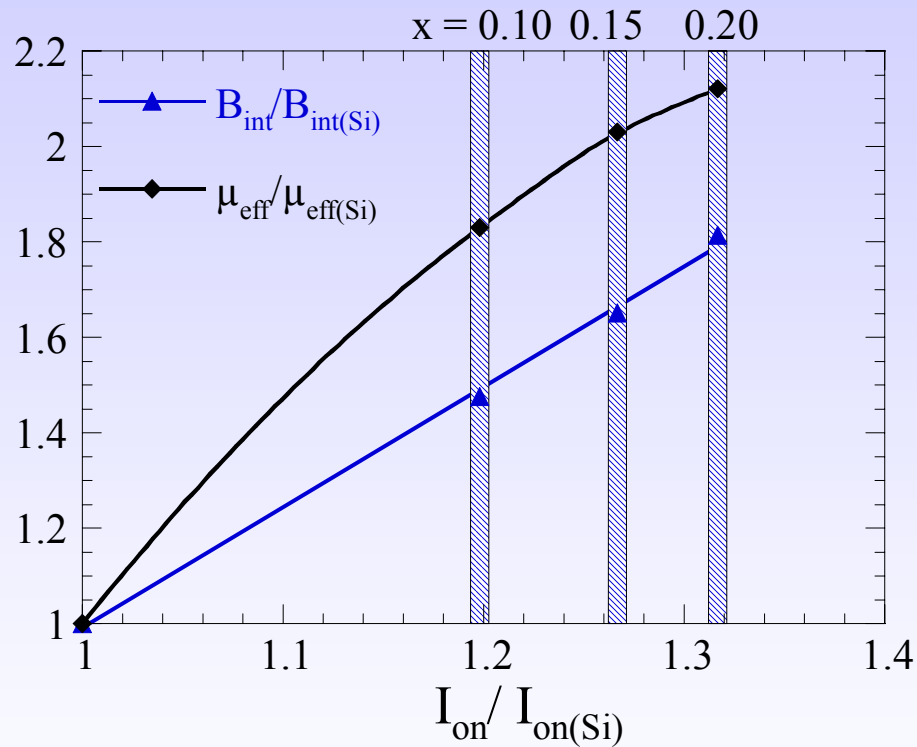
→  $\mu_{\text{eff}}$  saturation for  $x > 0.15$

→  $I_{\text{on}}$  and  $B_{\text{int}}$  increase similarly







# $I_{on}(B_{int})$ vs. $I_{on}(\mu_{eff})$



➔  $B_{int}$  more relevant than  $\mu_{eff}$  to account for  $I_{on}$   
( $B_{int}(I_{on})$  linear for  $B_{int} \in [15\%, 30\%]$ )



# Conclusions

- 
- ✓ Connections between  $B_{\text{int}}$  and:
    - channel length
    - strain
    - bias
  - ✓ High quasi ballistic influence for  $B_{\text{int}} < \approx 20 \%$
  - ✓  $B_{\text{int}}$  more relevant than  $\mu_{\text{eff}}$  to account for  $I_{\text{on}}$
-  Role of MOS architecture (*cf.* paper)